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In re Application of: NAGASAKA
Application No.: 10/589962
Filing Date: 18 August 2006
Attorney Docket No.: 128675
For: EXPOSURE METHOD, EXPOSURE APPARATUS,
EXPOSURE SYSTEM AND METHOD FOR
MANUFACTURING DEVICE

RESPONSE TO
STATUS INQUIRY

This communication is in response to the 17 April 2007 request for the status of the notification of acceptance and filing receipt for the above application.

Our records show that the application is in the initial processing phase, which currently takes approximately twelve to fifteen months. The notification of acceptance and filing receipt have not been mailed, however, your inquiry has been forwarded to the Office of Patent Application Processing. The application will be taken up in turn and the initial processing and review will be completed in due course.

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